IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Confirmation No. 1821

Mitsuhiro OKUNE et al.

Attorney Docket No. 2006_0772A

Serial No. 10/581,256

Group Art Unit 1792

Filed May 31, 2006

Examiner Mahmoud Dahimene

PLASMA ETCHING METHOD

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AMENDMENT UNDER 37 CFR § 1.116

DO-NOT ENTER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

OIL TO-ENTER

Sir:

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Responsive to the Office Action mailed December 24, 2008, please amend the above-identified application as follows.

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